

Attorney's Docket No.: 42P17283



Patent

~~IN THE UNITED STATES PATENT AND TRADEMARK OFFICE~~

In Re Application of:)
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)
McSwiney et al.)
) Examiner: Turocy, David P.
Application No: 10/750,062)
)
) Art Unit: 1792
Filed: December 30, 2003)
)
)
For: METHOD AND APPARATUS FOR)
LOW TEMPERATURE SILICON NITRIDE)
DEPOSITION)
)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated November 1, 2007, Applicants respectfully request that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia, 22313-1450, on:

February 25, 2008

Date of Deposit

Carrie Boccaccini

Name of Person Mailing Correspondence

Signature

Date

McSwiney et al.
Serial No : 10/750 062

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Examiner: Turocy, David P.
Art Unit: 1792